

28.



Attorney's Docket No. 42390.P4222D2

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#6/ Election
3/5/02
18

In Re Application of:

Robert S. Chau, et al.

Examiner: TRAN, Thien

U.S. Serial No: 09/654,315

Art Unit: 2811

Filed: September 1, 2000

I hereby certify that this correspondence is being deposited with the United States Patent Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, Washington, D.C. 20231

For: DEVICE STRUCTURE AND
METHOD FOR REDUCING
SILICIDE ENCROACHMENT

December 3, 2001
Date of Deposit
DIANNE NEATHERY
Name of Person Making Correspondence
Dianne Neathery
12/3/01
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FEB 1 2002

Commissioner for Patents
Washington, D.C. 20231

RESPONSE TO ELECTION REQUIREMENT

Dear Sir:

In Response to the Election Requirement mailed November 21, 2001, Applicants hereby elect to prosecute Group I claims, claims 30-37, drawn to a semiconductor device, and withdraw Group II claims, Claims 38-43 drawn to a process for making semiconductor devices.

If there are any additional charges, please charge them to our Deposit Account Number 02-2666.

Respectfully submitted,

BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN LLP

Date: 12/3, 2001

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